

FORM PTO-1449	Atty. Docket No. SEN-020	Serial No. 10/081,078
LIST OF PRIOR ART CITED BY APPLICANT	Applicant: Adam E. Norton et al.	
	Filing Date: February 21, 2002	Group: 2877 2872

U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Grant Date	Name	Class	Sub Class	Filing Date
CXC	AA	4,572,608	02/25/86	Mochizuki et al.	350	96.15
CXC	AB	4,922,309	05/01/90	Sekiwa et al.	356	300
CXC	AC	5,218,652	06/08/93	Lutz	385	11
CXC	AD	5,371,595	12/06/94	Nishiura et al.	356	350
CXC	AE	5,430,795	07/04/95	Taga et al.	359	179
CXC	AF	5,933,555	08/03/99	Shen	385	32
CXC	AG	6,040,906	03/21/00	Harhay	356	301
	AH					
	AI					
	AJ					

FOREIGN PATENT DOCUMENTS

Examiner Initial*	Document Number	Grant Date	Country	Class	Sub Class	Translation Yes	Translation No
	AK						
	AL						

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

CXC	AM	M.E. Lee et al., "Analysis of Reflectometry and Ellipsometry Data from Patterned Structures", Dept. of Electrical Engineering and Computer Science, Univ. of Michigan, MI, 5 pages.					
CXC	AN	Nasa Research Announcement, "Technical Details on OMI and Other EOS Chem Instruments", Sept. 29, 1999, 2 pages.					
CXC	AO	Varian Inc. paper, Scientific Instruments, "Polarizer and Depolarizer Accessory", June 28, 2000, 2 pages.					

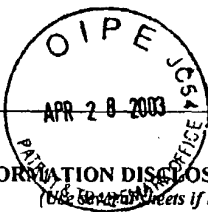
EXAMINER:

Craig H. Curtis

DATE CONSIDERED:

5 December '03

*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



INFORMATION DISCLOSURE CITATION
(Use separate sheets if necessary)

Docket Number (Optional)

TWI-30900

Application Number

10/081,078

Applicant(s)

Adam E. Norton et al.

Filing Date

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Group Art Unit

2877

2872

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
CXC	AA	5,657,121	08/12/1997	Nishina	356	327	10/16/1995
XXXX							

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
CXC	AB	1-287528	11/20/1989	Japan	G02B	27/28	Abstract	
CXC	AC	4-358115	12/11/1992	Japan	G02B	27/28	Abstract	
CXC	AD	0 665 452 A1	01/27/1995	EPO	G02B	6/26		

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner

Craig L. Curtin

Date Considered

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